THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: ONO, Toshiaki et al.

Group Art Unit: 1765

Serial No.: **09/883,922** 

Examiner: ANDERSON, Matthew A.

Filed: June 20, 2001

Confirmation No.: 3735

For: ME

METHOD OF MANUFACTURING EPITAXIAL WAFER AND METHOD OF

PRODUCING SINGLE CRYSTAL AS MATERIAL THEREFOR

Attorney Docket No.: 010789

Customer Number: 38834

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: March 3, 2004

Sir:

Applicants petition the Commissioner for Patents to extend the time for the Appeal Brief for one month from February 11, 2004 to March 11, 2004. A Notice of Appeal was filed on December 11, 2003.

Attached please find a check in the amount of \$440.00. This check includes \$110.00 to cover the cost of the extension and \$330.00 for filing an Appeal Brief. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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